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TO 76#1309022\*1725#1703 P.04/05

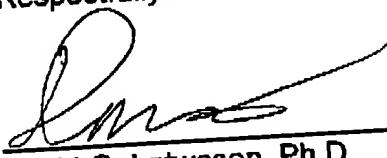
Appl. N . 09/932,236

REMARKS

Claims 24-41 are cancelled, leaving claims 1-23 pending in the application. In response to the Examiner's request for restriction of the claims in the application, applicant elects to prosecute the claims of group I (claims 1-23). Applicant requests substantive examination of pending claims 1-23 in the Examiner's next action.

Respectfully submitted,

Dated: 5/1/02

By:   
\_\_\_\_\_  
David G. Latwesen, Ph.D.  
Reg. No. 38,533

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Appl. No. 09/932,236

Application Serial No. .... 09/932,236  
Filing Date ..... August 16, 2001  
Inventor..... Hianing Yang  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 2813  
Examiner ..... Hogans, David L.  
Attorney's Docket No. ..... MI22-1725  
Title: Methods of Forming Metal-Comprising Materials and Capacitor Electrodes; and Capacitor Constructions

VERSION WITH MARKINGS TO SHOW CHANGES MADE ACCOMPANYING  
RESPONSE TO APRIL 19, 2002 OFFICE ACTION

In the Claims

The claims have been amended as follows. Underlines indicate insertions and strikeouts indicate deletions.

Cancel claims 24-41.

-END OF DOCUMENT-

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